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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Group Art Unit: 2811
Examiner: Hung K. Vu

In Re PATENT APPLICATION Of:

Applicants: Junichi HIKITA et al.)
Serial No: 10/797,018.)
Filed: March 11, 2004)
For: SEMICONDUCTOR CHIP AND)
PRODUCTION THEREOF, AND)
SEMICONDUCTOR DEVICE)
HAVING SEMICONDUCTOR)
CHIP BONDED TO SOLID DEVICE)
Docket No.: AI 257 D1)

**INFORMATION
DISCLOSURE
STATEMENT**

July 21, 2005

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

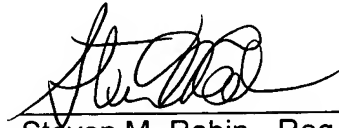
This is an Information Disclosure Statement submitted in compliance with the timing requirements of 37 C.F.R. §1.97(c)(2), i.e., after a first Office Action on the merits but before Final Rejection and/or Notice of Allowance.

Attached are copies of four Japanese Unexamined Patent Publications: No. 61-5549 with an English Abstract; 8-032060 with an English Translation; 2000-223653 corresponding to U.S. Patent 6,232,668; and 6-037143 corresponding to U.S. Patent 5,448,114. Japanese Unexamined Patent Publication No. 4-99537 has no English translation available. The Japanese publications were cited in a Japanese Office Action dated May 10, 2005 for the corresponding Japanese Patent Application No. 11-029842. The Japanese Action and its English translation are attached. Any relevance of the Japanese publications can be gleaned from the English translations. The publications are listed on the attached Form PTO-1449. Consideration of the documents is respectfully requested.

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It is hereby certified that each item of information contained in this Information Disclosure Statement was first cited in a communication from a foreign patent office in a counterpart foreign application not more than three months prior to the filing of this Information Disclosure Statement.

Respectfully submitted,



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July 21, 2005
Date

SMR:pjl



FORM PTO-1449 INFORMATION DISCLOSURE STATEMENT		Atty Docket		Application No.			
		AI 257D1		10/797,018			
		Applicant Junichi HIKITA et al.					
		Filing Date March 11, 2004		Group Unit 2811			
U.S. PATENT DOCUMENTS							
Examiner Initial		Document Number	Date	Name	Class	Sub-Class	Filing Date
	AA	6,232,668	05/15/01	Hikita et al.			
	AB	5,448,114	09/05/95	Kondoh et al.			
	AC						
	AD						
	AE						
	AF						
	AG						
	AH						
FOREIGN PATENT DOCUMENTS							
		Document Number	Date	Country	Class	Sub-Class	Translation
	AI	4-99537	08/27/92	Japan			No
	AJ	61-005549	01/11/86	Japan			Abstract
	AK	08-032060	02/02/96	Japan			Abstract
	AL	2000-223653	08/11/00	Japan			No
	AM	6-37143	02/10/94	Japan			No
	AN						
	AO						
OTHER (Including Author, Title, Date, Pertinent Pages, etc.)							
	AP						
	AQ						
	AR						
Examiner					Date Considered		
EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609; draw line through citation if not in conformance and not considered. Include copy of this form with next communication to Applicant.							